Recent Advances of MEMS Applications In Flow Control

Chiang Shih Fluid Mechanics Research Laboratory Mechanical Engineering Dept. Florida A& M University - Florida State University

Chih-Ming Ho Center for Micro Systems Mechanical and Aerospace Engineering Dept. University of California, Los Angeles

Cms Center for Micro Systems



Outline

□ Micro Electro Mechanical System

- > What is MEMS?
- > Why MEMS?
- □ Flow Control Issues
 - Physical parameters: Scale, Amplitude, Phase,
 - Location ...
 - Relevant Flow Physics
- □ Sample Flow Control Applications

Micro Electro Mechanical System (MEMS)

Miniaturized

A crown on an ant's head (Nippon Denso)



Integration



UCLA/Caltech

World's Smallest Steam Engine (Sandia Lab)



Batch Fabrication



General Motor's MAP sensors

MEMS Sensors

Spatial-temporal evolution

Whole-field sensing



Pressure sensor



1 M Hz Hot-wire ⇒ Velocity



0.02°C Temp. sensor



Shear stress sensor



Shear stress sensor array

Shear stress sensor skin



Backside contact sensor skin



V-shape shear stress sensor array



Flexible skin with sensor array





 $200 \text{ x} 200 \ \mu\text{m}^2$

- * 72 sensors in 1x3 cm² area.
- * Frequency response: 10 kHz
- * Thickness: 80 µm



MEMS off-plane actuator

Flap actuator







4 kHz



Array

Balloon actuator



symmetric



asymmetric



Array on the LE



- Square Substrate
- No Alignment
- Arbitrary Island Shape
- Simple Etching Step



Metal Actuator Skin





Asymmetric Balloon Actuation

MEMS in Flow Control



Understand Flow Physics

Capability to Perform Real-time Distributed Sensing and Control



Think - flow physics, simple & definitive Act - actuator, amplitude, frequency, phase

Sample MEMS Application I

□ Aerodynamic Delta Wing Flow Control
 ⇒ Scale matching: O(ε) ⇒ O(1)
 ⇒ Leading-edge vortex manipulation for UAV maneuver

Flow Separation

Before separation Boundary layer is thin, thickness δ

 $\frac{\partial P}{\partial s} > 0 \implies \text{Separation, Instabilities \& Stall}$ $\Rightarrow \text{Eruption of large vorticity flux}$ from the surface at the separation point

After separation

Wake formation

- Sensitive to local curvature variation: $\frac{\partial P}{\partial s}$
- Scale matches micro devices: $\delta \sim O(\epsilon)$
- Intrinsic flow amplifier:

 $O(\epsilon)$ perturbation $\Rightarrow O(1)$ effect

Dynamic Stall Vortex Control

Van Dommelen & Shen unsteady separation model: A **deterministic** particle collision process ⇒ explosive vorticity eruption Leads to the formation of a dynamic stall vortex ⇒ catastrophic breakdown



Pitching airfoil, ex: helicopter rotor blade

mm

Controlled, distributed ejection of surface vorticity \Rightarrow **redistribution** of the vorticity ejection

More manageable breakdown process



• Timely (phase detection by sensors) control is critical

Aerodynamic Control of a Delta Wing



Werle [1963]

- Leading-edge vortices contribute a significant portion of total lift
- Vortex lift : 40 % of total lift (at $\Lambda_{sweep}=56.5^{\circ}$, AOA=30°)

Symmetry breaking ==> **Aerodynamic torque**



- Boundary layer thickness ~ *O*(mm) => Length Scale Coupling
- Shear stress sensor array => Separation line detection
- Use micro actuators to control the separation => Symmetry breaking
- Vortex Control instead of camber control

Micro-scale Perturbation ==> Macro-scale Modification

Positive Rolling Moment





Actuation upstream of the separation line

Negative Rolling moment





Actuation downstream of the separation line

Shear Stress Level

AoA=5



• Separation line moves w.r.t. AoA • Strongly curved at high AoA • Distributed sensing & control



AoA=25

100

120

140

160

0.03

0.025

0.02

0.015

0.01

0.005



GRYPHON - A MEMS-UAV

Color CCD Camera with real-time down-link.

4 On-board Linear Accelerometers
2 Pitch and Yaw Rate Gyroscopes
2 Roll angle and rate Sensors
Nose boom with pressure, AOA, and Side-slip sensors

Main Flight CPU



High Sensitivity Flexible Shear Sensors







Sensors/Actuators Controller



Shear Stress Sensor Drivers



Bubble Actuators



ETO

MEMS

Advantages of MEMS-based Flow Control



Low radar visibility

Capability of integration

- High frequency response
- Better spatial resolution
- No traditional control device
- Smaller size
- Absence of sharp corners
- Smart transducer
- Distributed flow control

Accomplishments

New Aerodynamic Control Concept
 Vortex control instead of camber control

□ Large Torque Generated by Micro System

□ Independent control of Rolling, Pitching, and Yawing moments for Flight Maneuver

□ M³ - Micro-Sensor, Control, Actuator System

Sample MEMS Application II

□ Control of Supersonic Impinging Jets
 ⇒ Feedback loop attenuation
 ⇒ Adaptive control



Resonance Conditions

• Feedback loop driven flow configurations: Impinging tones, screech tones, cavity flows

• Effective control can be achieved by disrupting the coherence of the loop at its most susceptible region.





Interpretation Interpretation and the second second

Micro Jet Details

- Microjet diameter 400 μm
- Operating pressure 80- 120 psi
- Mass flow (total) ~ 0.4% 0.7% of main jet
- Operating gas Air
- \blacktriangleright Microjet inclination angle ~20^o









400 µm

luid mechanics research laboratory

Experimental Hardware



Parametric Space

NPR (Po/Pa)	= 3.7 & 5.0
h/d	= 2.0 - 60
Nozzle	= Mach 1.5
Microjet Press.	= 80 - 120 psi

DIAGNOSTICS:

- Unsteady Pressures
 Cround & Lift Plana
 - Ground & Lift Planes
- Acoustic.
- Mean Pressures
 - Ground & Lift Planes
- •Flow visualization
 - Shadowgraph
- PIV



Experimental Results Instantaneous Shadowgraphs



NPR=3.7, h/d=4, No Control



Experimental Results Instantaneous Shadowgraphs





NPR=3.7, h/d=4, No Control

With Control Absence of large scale structures luid mechanics research laboratory

mr

Experimental Results Noise and Unsteady Pressure Spectra

NPR 3.7, h/d=4.0



Ground Plane



Microphone



Iuid mechanics research laboratory

Experimental Results OASPL



• Performance gains not uniform over the entire operating range.

• Adaptive control is needed.

luid mechanics research laboratory



Experimental Results OASPL reduction

Microjet Pressure ~ 100 psia
OASPL reduction up to 14 dB for h/d=4

- Almost no reduction for h/d=4.5
- Extremely sensitive to h/d, therefore, real-time sensing is critical

NPR 3.7

luid mechanics research laboratory

Active Control Strategy

nozzle () (6) (6)

6

mrl

High-frequency pulsed jets thicken the nozzle shear layer, decreasing its receptivity to acoustic disturbances.





Microjets perturb the downstream-propagating instability waves, disrupting its coherent coupling with the acoustic waves. Accomplishments

Disruption of feedback loop using supersonic microjets

Attenuate tones as well as unsteady pressure
 fluctuations - reduction of OASPL can be more than
 10 dB for selected configurations

□ Control on demand - no performance degradation in off-position

Sample MEMS Application III

□ Turbulent Boundary Layer Control
 ⇒ Distributed sensing/control
 ⇒ Integrated M³ system for drag reduction

Near-Wall Streaks in Turbulent Boundary Layers



streak length ~ 1 cm life time ~ 1 msec

Highly unsteady

Real-time Distributed sensing and control

Drag reduction through structure manipulation

Passive devices : riblets
less than 8 % drag reduction
sensitive to Reynolds number change



Active schemes : interactive control • high drag reduction (~20%) • insensitive to Reynolds number change • needs real-time control • requires small and fast devices, MEMS !

Control Strategy

Counter-rotating vortex pair brings high-speed fluid down -Increase frictional drag

Flap actuator pumps fluid up to counteract this adverse effect

Real-Time Control Experiment Setup



Drag History of NN Controlled Flow



Off-line training: input weights converge, 18% drag reduction

On-line training: input weights converge, 20% drag reduction

Accomplishments

Drag reduction of a turbulent boundary layer can be achieved under laboratory condition

□ Control scheme can be adjusted according to different flow conditions.

□ Real-time sensing and control (M³) system developed

SUMMARY

□ Effective flow control on macro scale system can be achieved using micro devices

> Better understanding of flow physics is needed.

□ Integration of micro-sensor, micro-control logic and micro-actuator (a M^3 system) is the key for the future development of active flow control applications.



